

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3	((("20050074706") or ("20030001493") or ("20060220126")).PN.	US-PGPUB; USPAT	OR	OFF	2008/01/08 15:26
L2	118793	\$6resist with (metal\$3 conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:29
L3	356319	\$6lithograph\$3 ((mask reticle) same expos\$5 same (substrate wafer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:28
L4	9522	\$6resist with (metal\$3 with conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:53
L5	818	((electric near filed) potential voltage current) same 4	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:20
L6	274	3 and 5	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:31
L7	186	@ad<="20040414" and 6	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:26

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L8	57	7 and (ultra\$ violet UV)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:32
L9	1624	\$6resist near4(metal\$3 with conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:57
L10	26613	\$6resist near4(conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:57
L11	26613	\$6resist near4 (conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:57
L12	2593	((electric near filed) potential voltage current) same 11	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 15:58
L13	26	((electric near filed) potential voltage current) same 11 same (expos\$5 with (ultra\$ violet uv))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 16:02
L14	1	"823775".ap. and (conductive with resist)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 16:05

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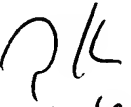
L15	0	"823775".ap. and (conductive with resist with metal\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 16:05
L16	1	"823775".ap. and (conductive with metal\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 16:05
L17	37998	((electric near filed) potential voltage current) same 3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:20
L18	10778	((electric near filed) potential voltage current) with \$6lithograph\$3	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:20
L19	1179	((electric near filed) potential voltage current) with ((mask reticle) same expos\$5 same (substrate wafer))	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 18:54
L20	11752	18 or 19	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:24
L21	11799	(photo\$resist) near4 (conduct\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:25

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L22	21955	(photo\$resist) with (ultra\$violet uv excimer laser)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:26
L23	80	20 and 21 and 22	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 17:26
L24	63	@ad<="20040414" and 23	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 18:56
L25	6	(electric near filed) with (((mask reticle) same expos\$5 same (substrate wafer)) \$5lithograph\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 18:56
L26	724	(electric near field) with (((mask reticle) same expos\$5 same (substrate wafer)) \$5lithograph\$3)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 18:56
L27	3	@ad<="20040414" and 21 and 22 and 26	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:11
L28	10	21 and 22 and 26	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:10

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L29	1770	(conductivity) with (photo\$resist)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12
L30	121	22 and 3 and 29	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12
L31	95	@ad<="20040414" and 30	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12
L32	506	(conductivity) near5 (photo\$resist)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12
L33	51	22 and 3 and 32	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12
L34	44	@ad<="20040414" and 33	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/01/08 19:12


 1/8/08